

**Notice of References Cited**

Application/Control No.

09/434,736

Applicant(s)/Patent Under

Reexamination

KIM ET AL.

Examiner

Evan T. Pert

Art Unit

2813

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* A	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification	
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B	US-5,318,923-	06-1994	Park	--	--
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

* U	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
U	Fink and Christensen, ELECTRONIC'S ENGINEERS' HANDBOOK, 1989, McGraw-Hill Book Company, Third Edition, pages 8-18 to 8-19.				
X V	Wolf, SILICON PROCESSING FOR THE VLSI ERA VOLUME 2: PROCESS INTEGRATION, 1990, Lattice Press, Chapter 4, pages 176-297.				
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.